



AF / JPL

Docket No.: M4065.0338/P338-A
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Richard H. Lane

Application No.: 09/989,372

Confirmation No.: 1348

Filed: November 21, 2001

Art Unit: 2814

For: ELECTROPOLISHED PATTERNED METAL
LAYER FOR SEMICONDUCTOR DEVICES

Examiner: T. T. Doan

REQUEST FOR RECONSIDERATION

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated July 26, 2005, finally rejecting claims 29-32, 34-39, 41, 44-47, 49 and 51-64, please reconsider the above-identified U.S. patent application in view of the following remarks: